# UTILITY POCKET NO. 8733.20079 First Inventor or Application Identifier TRANSMITTAL Title Polycrystalline Silicon Film Containing Ni

torney Docket No.	8733.20079
-------------------	------------

	4.				V		
	See	APPLICATION ELEMENTS MPEP chapter 600 concerning utility patent application contents	ADDI	RES	Assistant Commissioner for Patents SS TO: Box Patent Application Washington, DC 20231		
1.	⊠	Fee Transmittal Form (e.g. PTO/SB/17) (Submit an original and a duplicate for fee processing)			ACCOMPANYING APPLICATION PARTS		
			6.		Assignment Papers (cover sheet & document(s))		
2.	⊠	Specification Total Pages 14	7.		37 C.F.R. §3.73(b) Statement ☐ Power of Attorney (when there is an assignee)		
			8.		English Translation Document (if applicable)		
3.	Ø	Drawing(s) (35 U.S.C. 113) Total Sheets 17	9.		Information Disclosure Statement (IDS)/PTO-1449  Copies of IDS Citations		
			10.		Preliminary Amendment		
4.		Oath or Declaration Total Pages	11.	×	White Advance Serial No. Postcard		
-	a. b.	Convitrom a prior application (37 C F.R. &1 63(d))	12.		Small Entity Statement(s)  Statement filed in prior application. Status still proper and desired.		
1 11 11 11	U.	i. DELETION OF INVENTOR(S) Signed statement attached deleting inventor(s) named	13.	⊠	Certified Copy of Priority Document(s) (if foreign priority is claimed)		
. ]		in the prior application, see 37 C.F.R. §1.63(d)(2) and 1.33(b).	14.	⊠	Other: List of Inventors' Names & Addresses		
i, "			l		Request for Priority		
den den die den een met de Seen den	0	Incorporation By Reference (usable if box 4B is checked) The entire disclosure of the prior application, from which a copy of the oath or declaration is supplied under Box 4B, is considered to be part of the disclosure of the accompanying application and is hereby incorporated by reference therein.					
15.	If a	CONTINUING APPLICATION, check appropriate box, and supp	oly the	requi	isite information below:		
<b>15</b> .		Continuation   Divisional   Continuation-	in-pa	rt (C	, , , , , , , , , , , , , , , , , , , ,		
1111	Prior	application information: Examiner:			Group Art Unit:		
16.	Ame	nd the specification by inserting before the first line the se	enten	ce:			
		application is a □ Continuation □ Division plication Serial No. Filed on		Cont	tinuation-in-part (CIP)		
<b>;</b> 0	This	application claims priority of provisional application Seria	l No.		Filed		
	17. CORRESPONDENCE ADDRESS  LONG ALDRIDGE & NORMAN LLP 701 Pennsylvania Avenue, N.W. Washington, D.C. 20004 (202) 624-1200 FACSIMILE: (202) 624-1298						

Name:	Song K. Jung	Registration No.:	35,210
Signature:	Lamel D. Pari	Date:	2/4/00
Name:	RUSSELL O. PAIGE	Registration No.:	40 158

Docket No.

8733.20079

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) Jin JANG, et al.

**New Application** 

SERIAL NO: FILING DATE: Herewith

FOR:

Polycrystalline Silicon Film Containing Ni

#### FEE TRANSMITTAL

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

FOR	NUMBER FILED	NUMBER EXTRA	RATE	CALCULATIONS	
TOTAL CLAIMS	9 - 20 =	0	× \$18 =	\$0.00	
INDEPENDENT CLAIMS	4 - 3 =	1	× \$78 =	\$78.00	
□ MULTIPLE DEPENDEN	\$0.00				
■ LATE FILING OF DECI	■ LATE FILING OF DECLARATION + \$130 =				
	\$690.00				
	\$898.00				
□ REDUCTION BY 50% F	\$0.00				
□ FILING IN NON-ENGL	ISH LANGUAGE		+ \$130 =	\$0.00	
□ RECORDATION OF AS	SIGNMENT		+ \$40 =	\$0.00	
			TOTAL	\$898.00	

Please charge Deposit Account No. 50-0911 in the amount of

A duplicate copy of this sheet is enclosed.

REG. No. 40,758 for

A check in the amount of Ø

\$898.00

to cover the filing fee is enclosed.

The Commissioner is hereby authorized to charge any additional fees which may be required for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to Deposit Account No. 50-0911. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

LONG ALDRIDGE & NORMAN LLP

Sixth Floor

701 Pennsylvania Ave., N.W. Washington, D.C. 20004 Tel. (202) 624-1200

Fax. (202) 624-1298

Song K. Jung

Registration No.

35,210

Docket No.

8733.20079

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Jin JANG, et al.

FILING DATE: Herewith

FOR:

Polycrystalline Silicon Film Containing Ni

## LIST OF INVENTORS' NAMES AND ADDRESSES

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

Listed below are the names and addresses of the inventors for the above-identified patent application.

Jin JANG
 Hyundae Apt. 102-1103
 Chamwon-dong, Seocho-ku
 Seoul, KOREA

2.Seong-Jin PARK

1, Hoiki-dong, Dongdaemoon-ku

Seoul, KOREA

A declaration containing all the necessary information will be submitted at a later date.

Respectfully Submitted,

LONG ALDRIDGE NORMAN LLP

KEG. No. 40, 158 for

Song K. Jung

Registration No. 35,210

Sixth Floor
701 Pennsylvania Avenue, N.W.
Washington, D.C. 20004
For. (202) 624-1200
Fax. (202) 624-1298